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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kazuyoshi NAMBA

Serial No. : To Be Assigned

Group Art Unit: To Be Assigned

Customer No. : 00441

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For : SUBSTRATE CLEANING APPARATUS AND SUBSTRATE
CLEANING METHOD

LETTER ACCOMPANYING APPLICATION
FILED UNDER 37 CFR 1.52(d)

Hon. Commissioner for Patents
Washington, D.C. 20231

Sir:

The subject application is being filed in a foreign language (Japanese) under 37 C.F.R. 1.52(d). The enclosed Japanese language application includes 17 pages of written disclosure and 9 sheets of formal drawings.

This application is based on Japanese Patent Appln. No. 2000-259336 filed on August 29, 2000 and priority is claimed. Attached is a Claim For Foreign Priority and a certified copy of the foreign priority document.

A verified English language translation and signed Declaration will be filed in due course.

The filing fees with be paid in due course.

08/29/01
J1129 U.S. PTO


09/940855 08/29/01

J1050 U.S. PTO
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It is requested that correspondence in connection with this application be addressed to:

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Respectfully submitted,

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